



 Drafts

© Pending

Active

- L5 (989) ((MIM or Metal-Insulator-Metal or Metal adj Insulator adj Metal) near capacitor)
  - L6 (242) ((MIM or Metal-Insulator-Metal or Metal adj Insulator adj Metal) near capacitor) and (
  - L7 (47) ((MIM or Metal-Insulator-Metal or Metal adj Insulator adj Metal) near capacitor) and fi
  - L8 (10) ((MIM or Metal-Insulator-Metal or Metal adj Insulator adj Metal) near capacitor) and fi
  - L9 (79) ((MIM or Metal-Insulator-Metal or Metal adj Insulator adj Metal) near capacitor) and (
  - L10 (1) 9 and (landing adj pad adj type adj independent adj interconnection)
  - L11 (1) 5 and (landing adj pad adj type adj independent adj interconnection)
  - L12 (1) 5 and (independent adj interconnection)

Fated

- (0) ((MIM or Metal-Insulator-Metal or Metal adj Insulator adj Metal) near capacitor) and (first

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Durch den Erhalt der Mutterkunst wird die Mutterkunst nicht verhindert.

**BEST OF THE NIGHTMARES IN THIS ISSUE**

((MIM or Metal-Insulator-Metal or

							43 DR...	43 IS...	43 Pat...	43 Tech...
	U	I	Document ID	Issue Date	Pages	Title	Current DR	Current IS	Current Pat	Current Tech
1	<input type="checkbox"/>	<input checked="" type="checkbox"/>	US 20040115850 A1	20040617	20	A MICRODISPLAY PIXEL CELL AND METHOD OF MAKING IT	438/30		349/43; 438/239	
2	<input type="checkbox"/>	<input checked="" type="checkbox"/>	US 20040113190 A1	20040617	19	Integrated circuit devices including a MIM capacitor	257/296			
3	<input type="checkbox"/>	<input checked="" type="checkbox"/>	US 20040087101 A1	20040506	14	High K artificial lattices for capacitor applications to use in CU or AL BEOL	438/396		438/240; 438/638	
4	<input type="checkbox"/>	<input checked="" type="checkbox"/>	US 20040087098 A1	20040506	14	MIM AND METAL RESISTOR FORMATION AT CU BEOL USING ONLY ONE EXTRA	438/381			
5	<input type="checkbox"/>	<input checked="" type="checkbox"/>	US 20040084712 A1	20040506	12	Scaled EEPROM cell by metal-insulator-metal (MIM) coupling	257/314		438/257	
6	<input type="checkbox"/>	<input checked="" type="checkbox"/>	US 20040084707 A1	20040506	9	Finger metal-insulator-metal capacitor device with local interconnect	257/301		257/E21.018	
7	<input type="checkbox"/>	<input checked="" type="checkbox"/>	US 20040077141 A1	20040422	9	Capacitor and fabrication method thereof	438/240			
8	<input type="checkbox"/>	<input checked="" type="checkbox"/>	US 20040072406 A1	20040415	13	Structure and process for a capacitor and other devices	438/396			
9	<input type="checkbox"/>	<input checked="" type="checkbox"/>	US 20040009646 A1	20040115	19	Low temperature MIM capacitor for mixed-signal/RF applications	438/381			
10	<input type="checkbox"/>	<input checked="" type="checkbox"/>	US 20030234415 A1	20031225	10	Scalable three-dimensional fringe capacitor with stacked via	257/303			
11	<input type="checkbox"/>	<input checked="" type="checkbox"/>	US 20030219983 A1	20031127	11	Method of forming a MIM capacitor structure	438/694			